



Form PTO-1449 (Rev. 8-88)	Attorney Docket No. CYP01-042-CON-US	Serial No. 10/791,657
<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)	Applicant: Benjamin Schwarz, et al	
	Filing Date: March 2, 2004	Group: 2655

### U.S. PATENT DOCUMENTS

Examiner Initials*		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
CK	A1	4,174,251	11/1979	Paschke			
CK	A2	4,568,410	2/1986	Thornquist			
CK	A3	4,654,114	3/1987	Kadomura			
CK	A4	4,808,259	2/1989	Jillie, et al.			
CK	A5	5,279,705	1/1994	Tanaka			
CK	A6	5,928,967	7/1999	Radens, et al.			
CK	A7	5,989,979	11/1999	Liu, et al.			
CK	A8	6,235,644	5/2001	Chou			
CK	A9	6,296,780	10/2001	Yan, et al.			
CK	A10	6,307,174	10/2001	Yang, et al.			
CK	A11	6,379,872	4/2002	Hineman, et al.			
CK	A12	6,399,514	6/2002	Marks, et al.			
CK	A13	6,428,716	8/2002	Demmin, et al.			
CK	A14	6,451,703	9/2002	Liu, et al.			
CK	A15	6,461,969	10/2002	Lee, et al.			

Examiner Initials*		OTHER ITEMS - NON PATENT LITERATURE DOCUMENTS Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages
CK	A16	Wolf, "Silicon Processing for the VLSI Era", vol. 1-Process Technology, pp. 550-556, November, 1999.

Examiner <i>Christy Horvack</i>	Date Considered 1/20/06
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.